

Press Release



Rigaku Innovative Technologies

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Rigaku Innovative Technologies Presents High Performance Thin Film Coatings and Optics at SPIE Photomask Technology + EUV Lithography 2018

September 17, 2018, Monterey, CA. — Rigaku Innovative Technologies ([RIT](#)), a leading global supplier of multilayer optics for EUV lithography ([EUVL](#)), is pleased to announce its attendance at the [SPIE Photomask Technology + EUV Lithography 2018](#) meeting in Monterey, California.

[SPIE](#) is the international society for optics and photonics. The event takes place, Monday, September 17 through Thursday, September 20, 2018 at the Monterey Conference Center and Monterey Marriott in Monterey, California. RIT is presenting its high-reflectivity and precision coatings for collector, illumination, imaging and analysis optics for EUV lithography at booth 410.

RIT is the components division of Rigaku Corporation, and is a global supplier of high-performance multilayer optics used in commercial and academic institutions and government research facilities. RIT manufactures the most widely used brand of multilayers and X-ray source systems in the world for hard and soft X-ray analysis of liquid, powder or solid samples and is a global leader in the development and supply of EUV optics, shaping the vision of EUVL for high volume manufacturing.

About RIT

RIT is at the forefront of multilayer optic technology for EUV lithography. Formerly Osmic Inc., RIT was the first commercial supplier of multilayer optics for X-ray sciences. Since 1993, RIT has been a global leader in the development and supply of EUV optics, thus shaping the vision of EUVL for high-volume manufacturing. With hundreds of major innovations to its credit, Rigaku and its subsidiary companies are world leaders in the fields of small molecule and protein crystallography, X-ray spectrometry and diffraction, X-ray optics, as well as semiconductor metrology. Rigaku employs over 1,400 people globally and its products are in use in more than 90 countries – supporting research, development, production control and quality assurance activities. Throughout the world, Rigaku continuously promotes partnerships, dialog, and innovation within the global scientific and industrial community.

For additional information about RIT and its EUV related products, please visit:

www.rigaku.com/products/optics/euv

www.rigakuoptics.com

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